

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No. 3619

Tadashi MAEGAWA, et. al.

Date: December 29, 2006

Serial No.: 10/789,870

Group Art Unit: 1763

Filed: February 26, 2004

Examiner: Sylvia MacARTHUR

For: SUBSTRATE PROCESSING APPARATUS

VIA EFS WEB

Commissioner for Patents

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Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art cited in a communication from a foreign patent office in a counterpart foreign application, together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in connection with a corresponding patent application, to the best of applicant's knowledge, not more than three months prior to the filing of this Submission. A translation of the Office Action has been provided in lieu of a Statement of Relevancy of the present invention to the teachings of the cited prior art.

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Respectfully submitted,

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